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APPLICATION NO.	1	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/723,700	11/26/2003		Matthew J. Breitwisch	BUR920010088	7842
24241	7590	07/27/2004		EXAMINER	
IBM MICE		TRONICS ROPERTY LAW	EVERHART, CARIDAD		
	1000 RIVER STREET				PAPER NUMBER
972 E				2825	
ESSEX JUN	ICTION,	VT 05452	DATE MAILED: 07/27/2004		

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)					
	10/723,700	BREITWISCH ET AL.					
Office Action Summary	Examiner	Art Unit					
	Caridad M. Everhart	2825					
The MAILING DATE of this communication app Period for Reply	ears on the cover sheet with the c	orrespondence address					
A SHORTENED STATUTORY PERIOD FOR REPLY THE MAILING DATE OF THIS COMMUNICATION.  - Extensions of time may be available under the provisions of 37 CFR 1.13 after SIX (6) MONTHS from the mailing date of this communication.  - If the period for reply specified above is less than thirty (30) days, a reply - If NO period for reply is specified above, the maximum statutory period w - Failure to reply within the set or extended period for reply will, by statute, Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	36(a). In no event, however, may a reply be timer within the statutory minimum of thirty (30) day will apply and will expire SIX (6) MONTHS from cause the application to become ABANDONE	nely filed s will be considered timely. the mailing date of this communication. D (35 U.S.C. § 133).					
Status							
1) Responsive to communication(s) filed on	<u>_</u> .						
2a) This action is <b>FINAL</b> . 2b) ⊠ This	action is non-final.						
	Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.						
Disposition of Claims							
<ul> <li>4a) Of the above claim(s) is/are withdraw</li> <li>5) ☐ Claim(s) is/are allowed.</li> <li>6) ☒ Claim(s) <u>17-23</u> is/are rejected.</li> <li>7) ☐ Claim(s) is/are objected to.</li> </ul>	Claim(s) 17-23 is/are rejected.  Claim(s) is/are objected to.						
Application Papers							
9) The specification is objected to by the Examine 10) The drawing(s) filed on is/are: a) access applicant may not request that any objection to the Replacement drawing sheet(s) including the correct 11) The oath or declaration is objected to by the Ex	epted or b) objected to by the l drawing(s) be held in abeyance. See ion is required if the drawing(s) is ob	e 37 CFR 1.85(a). jected to. See 37 CFR 1.121(d).					
Priority under 35 U.S.C. § 119							
12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).  a) All b) Some * c) None of:  1. Certified copies of the priority documents have been received.  2. Certified copies of the priority documents have been received in Application No  3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).  * See the attached detailed Office action for a list of the certified copies not received.							
Attachment(s)							
<ol> <li>Notice of References Cited (PTO-892)</li> <li>Notice of Draftsperson's Patent Drawing Review (PTO-948)</li> <li>Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08) Paper No(s)/Mail Date <u>11-26-2003</u>.</li> </ol>	4)  Interview Summary Paper No(s)/Mail Da 5)  Notice of Informal P 6)  Other:						

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## Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

The factual inquiries set forth in *Graham* v. *John Deere Co.*, 383 U.S. 1, 148 USPQ 459 (1966), that are applied for establishing a background for determining obviousness under 35 U.S.C. 103(a) are summarized as follows:

- 1. Determining the scope and contents of the prior art.
- 2. Ascertaining the differences between the prior art and the claims at issue.
- 3. Resolving the level of ordinary skill in the pertinent art.
- 4. Considering objective evidence present in the application indicating obviousness or nonobviousness.

This application currently names joint inventors. In considering patentability of the claims under 35 U.S.C. 103(a), the examiner presumes that the subject matter of the various claims was commonly owned at the time any inventions covered therein were made absent any evidence to the contrary. Applicant is advised of the obligation under 37 CFR 1.56 to point out the inventor and invention dates of each claim that was not commonly owned at the time a later invention was made in order for the examiner to consider the applicability of 35 U.S.C. 103(c) and potential 35 U.S.C. 102(e), (f) or (g) prior art under 35 U.S.C. 103(a).

Claims 17-23 are rejected under 35 U.S.C. 103(a) as being unpatentable over Liaw (US 6,214,656B1).

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Liaw discloses forming p and n diffusion regions (Fig. 1 shows the p and n wells and col. 2, lines 60-65 discloses that they are formed). A polysilicon layer 16 is formed and part is n doped above the p well and part is p doped above the n well (col. 2, lines 64-67 and col. 3, lines 1-8 and Fig. 1 and Fig. 2). Silicide is selectively formed over the junction (Fig. 10 and col. 3, lines 56-67). The hardmask 36 prevents silicide formation over regions where it is not desired(col. 3, lines 50-54). The silicide is prevented from being formed on the n and p diffusion regions as shown in Fig. 14. It can be seen that the silicide forms an electrical connection between the n and the p diffusion regions. The steps are part of a process for completing formation of devices, which would include further back end of the line processes, as is implied by the disclosure that CMOS devices are formed in the disclosed process(col. 1, lines 7-10 and col. 4, lines 47-54). Liaw discloses that the formation of the silicide selectively and the prevention of the formation of the silicide on other areas reduces current leakage in the disclosure that autodoping is prevented (col. 4,lines 48-60). Although Liaw is silent with respect to GIDL, it would have been obvious to one of ordinary skill in the art that GIDL would also be prevented, as Liaw discloses that the source/drain may also not be silicided(col. 4,lines 55-60). Liaw is silent with respect to the well regions being p+ and n+, although Liaw does teach n and p wells. It would have been obvious to one of ordinary skill in the art at the time of the invention to have formed the diffusion regions as recited

because one of ordinary skill in the art would have been able to choose the

doping according to the desired characteristics of the of the device.

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Liaw is silent with respect to SRAM. It would have been obvious to one of ordinary skill in the art at the time of the invention to have applied the process taught by Liaw to SRAM because the components of SRAM are the same as those taught by Liaw.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Caridad M. Everhart whose telephone number is 571-272-1892. The examiner can normally be reached on Monday through Fridays 7:30-4:00.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Matthew S. Smith can be reached on 571-272-1907. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

CARIDAD EVERHUTT PRIMARY EXAMINER

C. Everhart 7-16-2004